AMENDMENTS TO THE CLAIMS

1. (currently amended) A method of performing digital optical communications to transmit an optical signal through an optical fiber, comprising the step of:

shaping the <u>a</u> waveform of the optical signal to <u>be being</u> transmitted through the optical fiber to increase <u>by increasing</u> the frequency thereof before the <u>waveform power</u> is stabilized, when the optical signal starts increasing in level at the <u>a</u> time the optical signal is applied to the optical fiber.



2. (currently amended) A semiconductor laser that modulates from a first level to a second level, comprising:

a diffraction grating for effecting distribution feedback, said diffraction grating having a normalized coupling coefficient kL of at least 2.0, said diffraction grating having a phase shift region disposed therein for achieving a phase shift of at most $\lambda/4$; and

an active layer having including a multiple quantum well structure, having a gain which saturation coefficient of greater than 0, such that said gain is saturated as a carrier concentration in the active layer increases.

- 3. (original) A semiconductor laser according to claim 2, further comprising a resonator, said phase shift region being disposed nearly centrally in said resonator.
- 4. (currently amended) A semiconductor laser according to claim 2, comprising: a diffraction grating for effecting distribution feedback, said diffraction grating having a normalized coupling coefficient kL of at least 2.0, said diffraction grating having a phase shift region disposed therein for achieving a phase shift of at most λ/4; and

an active layer including a gain, which is saturated as a carrier concentration in the active layer increases,

wherein said active layer has includes a multiple quantum well structure having growth surface irregularities.

5. (currently amended) A semiconductor laser according to claim 3, comprising:

a diffraction grating for effecting distribution feedback, said diffraction grating having a normalized coupling coefficient kL of at least 2.0, said diffraction grating having a phase shift region disposed therein for achieving a phase shift of at most $\lambda/4$;

an active layer including a gain, which is saturated as a carrier concentration in the active layer increases; and

a resonator, said phase shift region being disposed nearly centrally in said resonator, wherein said active layer has includes a multiple quantum well structure having growth surface irregularities.

6. (currently amended) A semiconductor laser according to claim 2, comprising: a diffraction grating for effecting distribution feedback, said diffraction grating having a normalized coupling coefficient kL of at least 2.0, said diffraction grating having a phase shift region disposed therein for achieving a phase shift of at most λ/4; and

an active layer including a gain, which is saturated as a carrier concentration in the active layer increases,

wherein said active layer has includes a multiple quantum well structure composed of comprising two stage potential quantum wells.

7. (currently amended) A semiconductor laser according to claim 3, comprising: a diffraction grating for effecting distribution feedback, said diffraction grating having a normalized coupling coefficient kL of at least 2.0, said diffraction grating having a phase shift region disposed therein for achieving a phase shift of at most λ/4;

an active layer including a gain, which is saturated as a carrier concentration in the active layer increases; and

a resonator, said phase shift region being disposed nearly centrally in said resonator, wherein said active layer has includes a multiple quantum well structure composed of comprising two stage potential quantum wells.

8. (currently amended) A semiconductor laser according to claim 2, comprising:

a diffraction grating for effecting distribution feedback, said diffraction grating having
a normalized coupling coefficient kL of at least 2.0, said diffraction grating having a phase



shift region disposed therein for achieving a phase shift of at most λ/4; and
an active layer including a gain, which is saturated as a carrier concentration in the
active layer increases,

wherein said active layer has includes a multiple quantum well structure including a non-radiative carrier recombination layer.

(currently amended) A semiconductor laser according to claim 3, comprising:
 <u>a diffraction grating for effecting distribution feedback, said diffraction grating having</u>
 <u>a normalized coupling coefficient kL of at least 2.0, said diffraction grating having a phase</u>
 <u>shift region disposed therein for achieving a phase shift of at most λ/4;</u>

an active layer including a gain, which is saturated as a carrier concentration in the active layer increases; and

a resonator, said phase shift region being disposed nearly centrally in said resonator, wherein said active layer has includes a multiple quantum well structure including a non-radiative carrier recombination layer.

10. (currently amended) A semiconductor laser according to claim 2, comprising: a diffraction grating for effecting distribution feedback, said diffraction grating having a normalized coupling coefficient kL of at least 2.0, said diffraction grating having a phase shift region disposed therein for achieving a phase shift of at most λ/4; and

an active layer including a gain, which is saturated as a carrier concentration in the active layer increases,

wherein said active layer has includes a multiple quantum well structure which is progressively thicker toward the center of the semiconductor laser in the axial direction of the resonator.

11. (currently amended) A semiconductor laser according to claim 3, comprising:
a diffraction grating for effecting distribution feedback, said diffraction grating having
a normalized coupling coefficient kL of at least 2.0, said diffraction grating having a phase
shift region disposed therein for achieving a phase shift of at most λ/4;

an active layer including a gain, which is saturated as a carrier concentration in the



active layer increases; and

a resonator, said phase shift region being disposed nearly centrally in said resonator, wherein said active layer has includes a multiple quantum well structure which is progressively thicker toward the center of the semiconductor laser in the axial direction of the resonator.

end

- 12. (original) A digital optical communication system comprising a semiconductor laser according to claim 2 as a communication light source.
- 13. (original) A digital optical communication system comprising a semiconductor laser according to claim 3 as a communication light source.
- 14. (new) A method of transmitting an optical signal through an optical fiber, comprising: modulating from a first level to a second level, a semiconductor laser; and after said modulating, increasing a frequency, f, of a relaxation oscillation, such that, df/dt > 0.
- 15. (new) A method of transmitting an optical signal through an optical fiber, comprising: modulating, from a first to a second level, a semiconductor laser; and after said modulating, providing an optical signal with a frequency, f, such that a magnitude of a stabilized state exceeds that of a local stabilized state during said modulating to produce a pulse compression.